



EV077334699
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

9-11-02
Muelish

Application Serial No. 09/920,978
Filing Date August 1, 2001
Inventorship Shane J. Trapp
Assignee Micron Technology, Inc.
Group Art Unit 2813
Examiner David S. Blum
Attorney's Docket No. MI22-1674
Title: Method of Forming Integrated Circuitry and Method of Forming Shallow
Trench Isolation in a Semiconductor Substrate

RESPONSE TO MAY 30, 2002 FINAL OFFICE ACTION
PRELIMINARY AMENDMENT TO ACCOMPANY RCE FILING

To: Box RCE
Assistant Commissioner for Patents
Washington, D.C. 20231

VIA U.S. EXPRESS MAIL

From: Mark S. Matkin (Tel. 509-624-4276; Fax 509-838-3424)
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Responsive to the Final Office Action dated May 30, 2002, Applicant
amends and remarks as follows:

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AMENDMENTS

In the Claims

Please replace the claims with the following clean version of the entire set of pending claims. Cancel all previous versions of any pending claim. A marked-up version showing amendments to any claims being changed is provided in one or more accompanying pages separate from this amendment. Any claim not accompanied by a marked-up version has not been changed relative to the immediate prior version, except that marked-up versions are not being supplied for any added claim or canceled claim.